

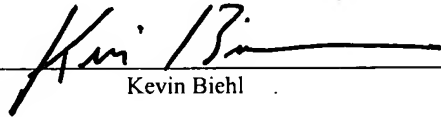
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jae-eun Park, *et al.*
Filing Date: Herewith
Title: METHOD FOR FORMING SILICON DIOXIDE FILM USING
SILOXANE

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2/19/04
Date


Kevin Biehl

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to prosecution on the merits, please amend the application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 12 of this paper.